

Instrumentation

Most of the components we supply to the instrumentation industry are from our valve and fitting lines. The rest, from our R&D 100 Award-winning pulsed discharge detectors to our application-dedicated trace gas analyzers, are primarily for gas detection and purification.

Pulsed Discharge Detectors

Non-Radioactive, Multiple Mode Electron Capture / Helium Photoionization

VICI PDDs (pulsed discharge detectors) utilize a stable, low powered, pulsed DC discharge in helium as an ionization source. Eluants from the column, flowing counter to the flow of helium from the discharge zone, are ionized by photons from the helium discharge. The bias electrode(s) focus the resulting electrons toward the collector electrode, where they cause changes in the standing current which are quantified as the detector output. Performance is equal to or better than detectors with conventional radioactive sources.

In the electron capture mode, the PDD is a selective detector for monitoring high electron affinity compounds such as freons, chlorinated pesticides, and other halogen compounds. For this type of compound, the minimum detectable quantity (MDQ) is at the femtogram (10⁻¹⁵) or picogram (10⁻¹²) level.

In the helium photoionization mode, the PDD is a universal, non-destructive, high sensitivity detector. The response to both inorganic and organic compounds is linear over a wide range. Response to fixed gases is positive (increase in standing current), with an MDQ in the low ppb range.

The PDD in helium photoionization mode is an ideal replacement for FIDs in petrochemical or refinery environments, where the hydrogen and flame can be problematic. In addition, when the discharge gas is doped with argon, krypton, or xenon (depending on the desired cutoff point), the PDD functions as a specific photoionization detector for selective determination of aliphatics, aromatics, amines, and other species.



R&D 100 AWARD WINNER

MORE INFORMATION

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Pulsed Discharge Detectors

Model D-2

The D-2 is a dual mode, universal detector system which can be retro-fitted to your older GC. The D-2-l is optimized for trace level work in the helium photoionization mode. The stand-alone systems include detector, controller, electrometer, helium purifier, and power supply.

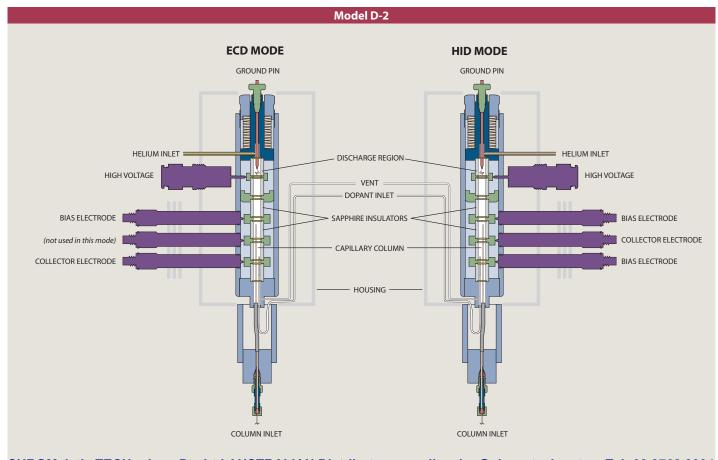


PDD Model D-2

Stand-alone system

Detector system includes detector cell, pulser, controller, electrometer, and helium purifier.

	110 VAC	230 VAC
Description	Prod No	Prod No
Mode-selectable universal electron capture / photoionization detector system	D-2	D-2-220
Detectors optimized for trace level work in helium photoionization mode Optimized for packed column use	D-2-I	D-2-I-220



Pulsed Discharge Detectors

Plug-and-play detectors for Agilent 6890 and 7890

Model D-3 is designed for plug-andplay installation on the popular Agilent 6890 and 7890, and is optimized for trace level work in the helium photoionization mode Model D-5 is a plug-and-play electron capture detector for the 6890.

All versions utilize the electonics and power supply of the host GC.



PDD Model D-3

Helium photoionization

Detector optimized for trace level work in helium photoionization mode

	110 VAC	230 VAC
Description	Prod No	Prod No
Plug-in system for Agilent 6890	D-3-I-HP	D-3-I-HP-220
Plug-in system for Agilent 7890	D-3-I-7890	D-3-I-7890-220

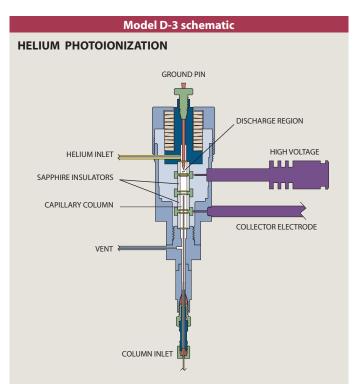
PDD Model D-5

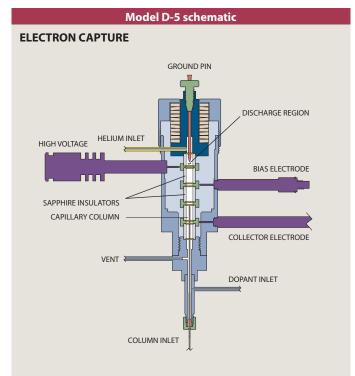
Electron capture

Detector optimized for electron capture detection

 Description
 Prod No
 Price
 Prod No

 Plug-in system for Agilent 6890
 D-5-6890
 D-5-6890-220





Pulsed Discharge Detectors

Plug-and-play detectors for other GCs

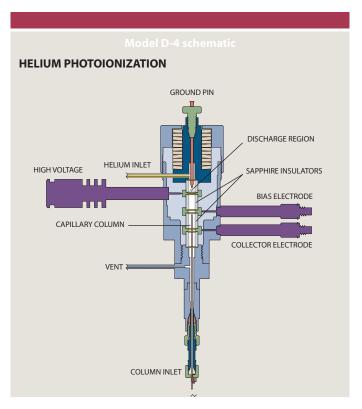
Pulsed Discharge Detector Model D-4 is available in versions for easy installation on most of the GCs in current use, including the Varian 3800, Shimadzu 14 and 17, ThermoFinnigan Trace, Mega, and Top, and Hewlett Packard 5890. The D-4 is single mode, optimized for trace level work in the helium photoionization mode.

PDD Model D-4

Helium photoionization

Detectors optimized for trace level work in helium photoionization mode

	110 VAC	230 VAC	
Description	Prod No	Prod No	
Specialized detector for			
HP 5890	D-4-I-HP58	D-4-I-HP58-220	
Shimadzu GC 14 *	D-4-I-SH14-R	D-4-I-SH14-R-220	
Shimadzu GC 17 *	D-4-I-SH17-R	D-4-I-SH17-R-220	
Thermo Trace GC *	D-4-I-TQ-R	D-4-I-TQ-R-220	
Varian 3800 *	D-4-I-VA38-R	D-4-I-VA38-R-220	
* Uses existing GC FID electrometer.			
For all other GCs	D-4-I	D-4-I-220	



Pulsed Discharge Detector Applications

HERBICIDES IN SOIL SAMPLES USING EPA METHOD 8151

Detector: PDD Model D-2
Mode: Electron capture
Sample: Environmental soil (1 g)

Detector temp: 320°C

Column: ValcoBond VB-5

30 m x 0.25 mm x 0.25 μm Column temp: 60°C (2 min),

Column temp: 60°C (2 min), 20°C/min to 180°C,

4°C/min to 220°C,

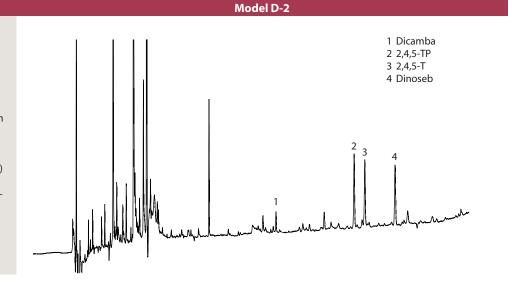
40°C/min to 300°C (5 min) p: 200°C

Injector temp: 200°C Sample volume: 2 µL (solvent microextrac-

tion), 1:15 split

Discharge gas: Helium
Dopant gas: Helium/argon

Attenuation: 1



PAH RESIDUES IN AN ENVIRONMENTAL SOIL SAMPLE SPIKE

Detector: PDD Model D-2 Mode: Helium photoionization Sample: Environmental soil (1 g)

Detector temp: 300°C

Column: ValcoBond VB-35

30 m x 0.25 mm x 0.25 μm 120°C for 3 min, 15°C/min

Column temp: 120°C for 3 min, 15°C/mi to 310°C for 15 min

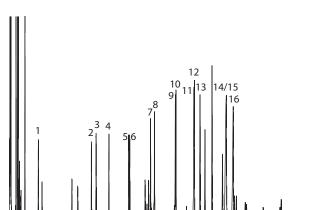
Injector temp: 275°C

Sample volume: 2 µL (solvent microextrac-

tion), 1:15 split
Discharge gas: Helium

Discharge gas: Heliur
Dopant gas: none
Attenuation: 1

PDD Model D-2



- 1 Naphthalene
- 2 Acenaphthalene
- 3 Acenaphthene
- 4 Fluorene
- 5 Phenanthrene
- 6 Anthracene
- 7 Fluoranthene
- 8 Pyrene
- 9 1,2 Benzanthracene
- 10 Chrysene
- 11 Benzo(b)fluoranthene
- 12 Benzo(k)fluoranthene
- 13 Benzo(a)pyrene
- 14 Indeno (1,2,3-C.d)pyrene
- 15 1,2:5,6-Dibenzanthracene
- 16 1,12-Benzoperylene

AIR

Detector: PDD Model D-3

Helium photoionization

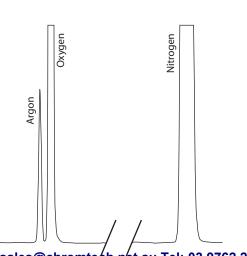
Detector temp: 300°C

Column: ValcoPLOT VP-Molesieve

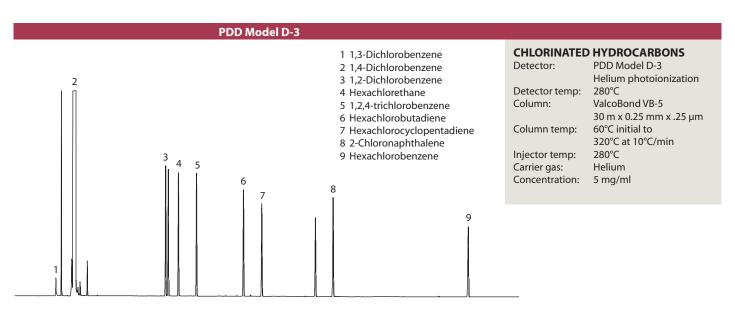
30 m x 0.53 mm x 0.50 μm

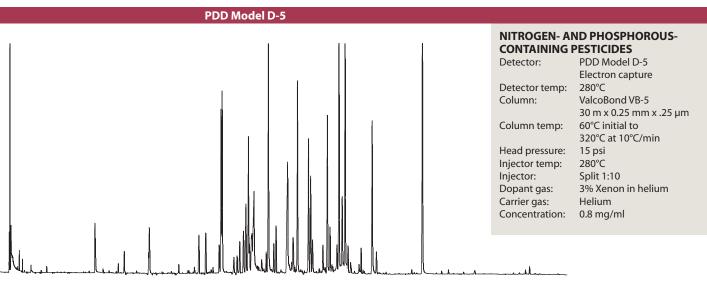
Column temp: Ambient Injector temp: 250°C Discharge gas: Helium Carrier gas: Helium

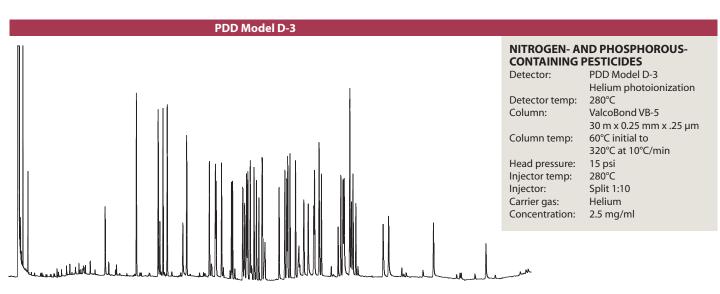




Pulsed Discharge Detector Applications







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Gas Purifiers

Helium and Nitrogen Purifiers

Carrier gas purity is essential in any application requiring extreme sensitivity. Impurities limit detector sensitivity and can even destroy capillary columns. The Valco HP2 provides "point-of-use" purification of helium or other noble gases, such as Ar, Ne, Kr, and Xe, to sub-ppm levels of reactive gaseous impurities. The NP2 is similar, purifying nitrogen to sub-ppm levels of gaseous impurities.

The purification substrate in Valco gas purifiers is a non-evaporable gettering alloy. This stable alloy is contained in a welded assembly, so the purifiers can be used safely in industrial applications with minimal precautions. The getter is activated by heating, which eliminates the oxide film on the particle surface and allows helium to diffuse into the bulk of the getter particles. The HP2 and NP2 feature a self-regulating design which eliminates the possibility of thermal runaway and maintains the getter material at the optimum temperature.



Standard helium and nitrogen purifiers

Includes universal power supply.

Helium purifier Nitrogen purifier

Description Prod No Prod No

110 VAC HP2 NP2
230 VAC HP2-220 NP2-220

Replacement getter assembly

Helium I-23572HP2 Nitrogen I-23572NP2

HELIUM PURIFIER

■ CE certified

■ Gases purified He, Ne, Ar, Kr, Xe, Rn

■ Maximum operating pressure 1000 psig

Impurities removed

Outlet impurities less than 10ppb H_2O , H_2 , O_2 , N_2 , NO, NH_3 , CO, CO_2 , and CH_4 , based on 10ppm total inlet impurities. Other impurities removed include CF_A , CCI_A , SiH_A and light hydrocarbons.

■ Impurities *not* removed He, Ne, Ar, Kr, Xe, Rn

NITROGEN PURIFIER

CE certified

Gases purified N_2 only

Impurities removed

Outlet impurities less than 10ppb $\rm H_2O, \rm H_2, \, O_{2^t}$ NO, NH $_3$, CO, CO $_{2^t}$ and CH $_{4^t}$ based on 10ppm total inlet impurities. Other impurities removed include $\rm CF_{4^t} \, CCl_{4^t} \, SiH_4$ and light hydrocarbons.

■ Impurities *not* removed

He, Ne, Ar, Kr, Xe, Rn, N₂

Gas Purifier and Thermal Conductivity Detector



Miniature Gas Purifiers

The Valco Miniature Helium Purifier (HPM) and Miniature Nitrogen Purifier (NPM) are designed to be installed in a gas chromatograph's flow path immediately upstream of the injector.

The HPM/NPM will remove any contaminants introduced by flow controllers, elastomeric tube seals, pressure regulators, crude traps, or other system components that are not completely clean and leak-tight.

Mini helium and nitrogen purifiers

Includes universal power supply.

	Helium purifier	Nitrogen purifier
Description	Prod No	Prod No
110 VAC	HPM	NPM
230 VAC	HPM-220	NPM-220



Microvolume Thermal Conductivity Detector

Our dual filament TCD is a stand-alone unit consisting of the detector housing and a controller with electrometer and temperature controls. The detector cell includes two separate nickel/iron filaments, capable of independent or referenced (differential) operation. Cell volume and geometry are optimized for capillary chromatography and enhanced sensitivity at low flow

rates. (Recommended total flow rate: 2-10 mL/min.) Thermal stability is maintained to ±0.02°C, resulting in a stable, noise-free signal. A single 0-1 millivolt attenuated output for a strip chart recorder is provided through the signal cable at the rear of the controller, with 0-1 volt and 0-10 volt unattenuated signals available through the remote signal cable.

TCD Thermal conductivity detectors

		110 VAC	230 VAC
Description		Prod No	Prod No
Entire unit (cell and electro	onics)	TCD2-NIFE	TCD2-NIFE-220
Cell/oven assembly only	Dual filament	TCD2-NIFED	TCD2-NIFED-220
TCD controller only		TCD2-C	TCD2-C-220

